1 Ozone Generation from a Germicidal Ultraviolet Lamp with Peak

2 Emission at 222 nm

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6 Abstract

Recent interest in commercial devices containing germicidal ultraviolet lamps with a peak
emission wavelength at 222 nm (GUV222) has focused on mitigating virus transmission indoors
and disinfecting indoor spaces while posing minimum risk to human tissue. However, 222 nm
light can produce ozone (O₃) in air. O₃ is an undesirable component of indoor air because of
health impacts from acute to chronic exposure and its ability to degrade indoor air quality
through oxidation chemistry. We measured the total irradiance of one GUV222 lamp at a
distance of

5 cm away from the source to be 27.0 W m⁻² \pm 4.6 W m⁻² in the spectral range of 210 nm to 230 14 15 nm, with peak emission centered at 222 nm and evaluated the potential for the lamp to generate O₃ in a 31.5 m³ stainless steel chamber. In seven four-hour experiments average O₃ mixing 16 ratios increased from levels near the detection limit of the instrument to 48 ppb_y \pm 1 ppb_y (94 µg 17 $m^{-3} \pm 2 \mu g m^{-3}$). We determined an average constant O₃ generation rate for this lamp to be 1.10 18 mg $h^{-1} \pm 0.15$ mg h^{-1} . Using a radiometric method and chemical actinometry, we estimate 19 effective lamp fluences that allow prediction of O₃ generation by the GUV222 lamp, at best, 20 21 within 10 % of the measured mixing ratios. Because O₃ can react with gases and surfaces indoors

- 22 leading to the formation of other potential by-products, future studies should evaluate the
- 23 production of O₃ from GUV222 air cleaning devices.

24 Keywords

25 Air cleaning, germicidal ultraviolet light, ozone, indoor air quality

26 **TOC**



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28 Introduction

The on-going COVID-19 pandemic has highlighted the need for effective, in room, low energy air cleaning devices to enable safer in-person interactions in indoor environments.^{1,2,3} Portable cleaning devices use a range of technologies that may have uncharacterized impacts on indoor air quality.⁴ These impacts could result in human exposure to pollutants that are at odds with the intended benefit of the technology.⁵ One such technology is germicidal ultraviolet lamps that operate with a peak emission wavelength at 222 nm (GUV222). This wavelength is appealing as

research to date indicates it does not significantly penetrate human skin and is effective at
 inactivating pathogens.^{6,7,8}

Air cleaning devices equipped with GUV222 lamps are of particular importance when considering the potential for ozone (O₃) formation. In the range of 175 nm to 242 nm, molecular oxygen (O₂) will absorb light and dissociate with a quantum yield of unity to produce two ground state oxygen atoms (O), via reaction 1, that can then go on to recombine with O₂, in a termolecular reaction involving a collisional body ($M = N_2$ or O₂), to form O₃ via reaction 2.⁹, ^{10,11}

$$O_2 + hv \ (\lambda = 175 - 242 \ nm) \to 20$$
 (1)

$$0 + O_2 + M \rightarrow O_3 + M \tag{2}$$

Reactions 1 and 2 are two of the four reactions comprising The Chapman mechanism which 45 describes the production of O₃ in the stratosphere.¹² Characterization of spectral output and 46 potential for O₃ production is necessary when considering the application of GUV222 devices 47 for mitigating virus transmission while maintaining good air quality in indoor environments. 48 While O₃ itself can be a harmful by-product of air cleaner operation¹³, it can also react with gases 49 and surfaces indoors¹⁴—including human skin¹⁵—leading to the formation of other potentially 50 concerning by-products such as gas-phase aldehydes and ultra-fine particulate matter.¹⁶ Of 51 particular concern is the exposure to O₃ and O₃-generated indoor pollutant by-products from 52 application of multiple GUV222 units in small and/or poorly ventilated indoor spaces.¹⁷ Here we 53 present measurements of O₃ generation from a commercial GUV222 lamp in a stainless-steel 54 laboratory chamber, support our O₃ formation observations with a chemical kinetic model, and 55

determine O₃ generation rates for this GUV222 lamp that can be used in future evaluations of
GUV222 technologies in indoor spaces.

58 Methods

59 Measurement of the GUV222 Lamp Emission Spectrum. Spectral irradiance measurements of a krypton chloride (KrCl) excimer GUV222 lamp were performed with a commercial UV 60 spectrometer (Mightex Systems model: HRS-UV1-025) with detection sensitivity in the spectral 61 range of 200 nm to 415 nm. GUV222 emission light was collected by an integrating sphere 62 detector that was connected to the spectrometer by a UV-transmitting optical fiber patch cable. 63 64 Wavelength calibration of the spectrometer was achieved by use of spectral calibration lamps 65 with well-defined emission peaks. For the spectral irradiance calibration, an internal FEL lamp setup was used to establish the absolute scale in the 300 nm to 400 nm range, and this scale was 66 67 tied (tie point at 310 nm) to an unscaled spectral calibration factor that was obtained from a deuterium lamp in the 200 nm to 340 nm range. This process yielded a continuous absolute 68 spectral calibration factor from 210 nm to 415 nm for the UV spectrometer. We estimate the 69 70 uncertainty (k=2) of the spectral irradiance measurements at 222 nm to be 17 %.

Operation of Chamber and Experiment Design. We operated the commercial GUV222 lamp in a 31.5 m³ environmentally controlled walk-in chamber instrumented to measure O₃ (Thermo 49iq O₃ monitor) and sulfur hexafluoride (SF₆; proton-transfer mass spectrometry) to measure the chamber air change rate (Figure S8). The O₃ monitor was calibrated to the NIST Standard Reference Photometer prior to the study.¹⁸ A series of seven experiments were conducted to measure O₃ production from the GUV222 lamp. Prior to the experimental series the chamber was passivated with 100 ppb_v of O₃ for ten hours. A metal fan was placed in the chamber to

78	facilitate mixing. The GUV222 lamp was positioned in the upper corner of the chamber pointed
79	down and towards the center of the chamber opposite of the fan (Figure S4).
80	Prior to each experiment we operated the chamber to achieve a temperature of 20 $^\circ$ C and 50 $\%$
81	relative humidity. At the beginning of each experiment temperature and humidity control was
82	stopped and the vents controlling the recirculation of air were closed. The average temperature
83	during the experiments was 22.5 °C \pm 1.3 °C, and the average relative humidity was 42.8 % \pm
84	6.0 %. The GUV222 lamp was then turned on for four hours over which O_3 concentration was
85	measured. SF ₆ was injected into the chamber at the start of each experiment and air change was
86	determined from the first order loss constant (Figure S8). Tetrachloroethylene was vaporized and
87	introduced to the chamber at the beginning of four of the experiments to measure the effective
88	photon flux via actinometry (e.g., Peng, et al. 2023) ¹⁹ .

89 **Results**

90 GUV222 Lamp Emission Spectrum. Figure 1a shows the spectral irradiance versus wavelength

of the GUV222 lamp measured directly under and at several distances from the lamp.



Figure 1. (a) GUV222 lamp emission spectra showing peak emission at 222 nm measured at six different distances. (b) The total irradiance versus distance showing a drop-off proportional to $1/d^{1.52}$.

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The main emission peak is at 222 nm, as reported by other studies examining emission spectra of 97 KrCl lamps²⁰, accompanied by a lower-wavelength tail distribution.²¹ By integrating under the 98 spectral irradiance curve over the entire emission range, the total irradiance can be calculated and 99 100 plotted as a function of distance from the lamp (Figure 1b). The total irradiance in the immediate vicinity of the lamp is high (105 W m⁻² at 0 cm and 27 W m⁻² at 5 cm) but drops very quickly 101 with distance. This drop-off follows the relationship, $E \sim 1/d^{1.52}$, where E is irradiance and d the 102 distance from the lamp. 103 Measurement and Modeling of O₃ Production from the GUV222 Lamp. We measured 104

elevated levels of O_3 in our chamber after four hours of GUV222 lamp operation as shown in

Figure 2.



Figure 2. The average O_3 mixing ratio from seven GUV222 lamp experiments is shown as the solid black line with the variability (2σ) shown by the gray shaded area. The average and standard deviation of seven modeled O_3 mixing ratios is shown as determined by the irradiance method in dark red and actinometry method in light red. The O_3 measured from the experiment where the light was blocked is shown in purple.

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Four hours after turning the GUV222 lamp on, we observed 48 ppb_y \pm 1 ppb_y (94 µg m⁻³ \pm 2 µg 114 m⁻³) of O₃ in the chamber. To rule out the influence of other physical phenomena related to 115 operation of the GUV222 lamp (e.g., electrical arcing¹³) being responsible for O₃ production we 116 operated the lamp, for one experiment, with the output of the lamp covered to prevent light from 117 illuminating the chamber. No O₃ generation was observed in that experiment (Figure 2, purple 118 trace) providing evidence that photolysis of O₂ at 222 nm was responsible for production of O₃. 119 At the end of each experiment the lamp was turned off and the decay of O₃ was measured 120 (Figure S6). We assume that O_3 is lost to stainless steel chamber surfaces and homogeneous gas-121

phase reactions via a first order process. Additionally, some O_3 is lost via air change which was 122 quantified from SF₆ decay measurements (≈ 6 %; Figure S8). We determine the rate constant 123 from a linear fit of the natural log of O_3 mixing ratio versus time (equation 3). 124 $\ln([O_3]) = -(k_{\dot{V}} + k_{decav})t$ (3) 125 In equation 3, k_{decay} is the first order rate constant for loss of O₃ to the chamber surfaces and 126 homogeneous gas-phase reaction, $k\dot{y}$ is the air change rate (h⁻¹), and t is time. Rates of O₃ decay 127 (k_{decay}) remained relatively constant throughout the experiments only varying by 2 %. 128 We calculate theoretical O₃ production from the GUV222 using chemical production and loss 129

and physical loss terms in equation 4.

131
$$\frac{d[O_3]}{dt} = 2j_{O2}[O_2] - \frac{2k_1 j O_3[O_3]^2}{k_2 [O_2][M]} - (k_{\dot{V}} + k_{decay})[O_3]$$
(4)

The first term on the right hand side of the equation is the O₃ production from photolysis of O₂ at 222 nm, the second term accounts for loss of ozone through the odd-oxygen (O_x = O₃ + O) steady-state ($k_1 = 7.96 \times 10^{-15} \text{ cm}^3$ molecule⁻¹ s⁻¹; $k_2 = 6.10 \times 10^{-34} \text{ cm}^6$ molecule⁻² s⁻¹), and depositional loss to chamber walls and homogeneous gas-phase reactions is accounted for in the measured k_{decay}. The odd-oxygen steady-state is established from the rapid production of oxygen atoms (O) from both O₂ and O₃ photolysis (jO₃ is the photolysis rate constant for O₃) and the recombining of O with O₂ to form O₃.

As shown in equation 4, the photolysis rate of O_2 drives O_3 production from the GUV222 lamp

and the first-order photolysis rate constant (jO₂) is strongly dependent on the photon flux (F;

141 equation 5) from the lamp.

142
$$j_{02} = \int \sigma_{02} \Phi_{02} F \, d\lambda$$
 (5)

143	Using the measured irradiance spectrum (Figure 1) from the lamp we calculate an effective O_2
144	absorption cross section $(\sigma_{02})^9$ of 4.30 x 10^{-24} cm ² across a wavelength (λ) range between
145	210 nm and 230 nm (compared to 4.09 x 10^{-24} cm ² at 222 nm). The photolysis quantum yield of
146	$O_2(\Phi_{02})$ between 210 nm and 230 nm is unity. ²² We estimate an effective photon flux (F) from
147	the GUV222 lamp from two different methods: (1) by determining the average of the measured
148	irradiance projected into a cone (irradiance method) and (2) following the method of Peng, et al.
149	$(2023)^{19}$, using chemical actinometry ²³ with tetrachloroethylene (C ₂ Cl ₄) as the actinometer
150	(actinometry method).
151	Briefly, for the irradiance method, we generated an irradiance field within a 31.5 m ³ cone by
152	expanding the GUV222 lamp irradiance point source axially following the relationship, $E \sim$
153	$1/d^{1.52}$, and angularly following a relatively tight half-angle of $\approx 55^{\circ}$ (equation S4). We then
154	averaged the projected irradiance over the emission volume to get the effective photon flux. For
155	the actinometry method, C ₂ Cl ₄ was introduced to the chamber and the GUV222 lamp was turned
156	on for four hours to measure the C ₂ Cl ₄ photolysis rate. Using the measured C ₂ Cl ₄ photolysis rate,
157	effective cross section (σ_{C2C14}), and reported photolysis quantum yield (Φ_{C2C14}), we determined
158	the effective photon flux (equation S8). Between 210 nm and 230 nm, effective GUV222 lamp
159	powers of 32.7 mW m ⁻² and 21.7 mW m ⁻² were determined from the irradiance method and
160	actinometry, respectively. Details of the effective photon flux determination methods are
161	discussed in the supplemental information.

162 The models both show rapid production of O_3 early in the experiment and on the approach to 163 steady-state conditions. This rapid rise in O_3 concentration is due to photolytic production and 164 the relative lack of non-photolytic loss and is consistent with the measured data. For the

irradiance method, O₃ levels are over-predicted by \approx 33 %. We expect over-estimation of the 165 effective photon flux using this irradiance method because we are not accounting for attenuation 166 of the incident radiation by interactions with the chamber walls. Ma, et al. (2023) recently 167 demonstrated that different types of stainless steel reflect 222 nm light reflect with an efficiency 168 of ≈ 20 %.²⁴ The 31.5 m³ modeled conical irradiance field slightly extends beyond the chamber 169 170 walls, but the lamp was positioned in a corner of the chamber such that a large volume of the chamber air was irradiated by the UV light, therefore, our model should be mostly valid. In 171 reality, a majority of the ozone is created within 2 m of the lamp (Table S1), so the cone 172 173 extending beyond the chamber walls results in small overestimation of ozone production. Accurately accounting for reflectance and exact chamber dimensions would decrease the 174 effective photon flux and thus modeled O₃ production. 175 In contrast, for the actinometry method, the model underpredicts O_3 levels by ≈ 11 %. An 176 effective lamp power of 23 mW m⁻² (k_{decav} = 0.17 h⁻¹) would be needed to reconcile the 11% 177 deficit in modeled O₃ production, which is captured by the measured variability of the effective 178 photon flux determined from actinometry (21.7 ± 1.7 W m⁻²). Despite some discrepancies 179 between modeled and measured O₃, our calculations provide evidence to suggest the mechanism 180 181 of O₃ production from GUV222 lamps is likely photolysis of O₂ from 222 nm light, and not from other physical phenomena. 182

183 Determination of O₃ Generation Rates from GUV222 Lamps. In the chamber experiments O₃ 184 was generated from the GUV222 lamp while simultaneously being lost through air change, gas-185 phase reactions, and deposition to surfaces. Thus, the O₃ production rate from the lamp can be 186 determined by solving for the generation rate (GR) in the transient solution to the mass balance 187 equation presented in equation 5.

188
$$[0_3]_t = [0_3]_i e^{-(k_V + k_{decay})t} + \frac{\frac{GR}{V}}{(k_V + k_{decay})(1 - e^{-(k_V + k_{decay})t})}$$
(6)

- 189 Where $[O_3]_i$ and $[O_3]_t$ are the initial and time t O_3 mixing ratios, V is the volume of the chamber
- 190 (31.5 m³), and GR is the O_3 generation rate (μ g m⁻³).
- 191 Calculated O₃ production rates from the GUV222 lamp, presented in Table 1, varied within 2%.
- **Table 1.** Summary of O₃ decay constants, air change rates, and O₃ generation rates.

Experiment	k _{decay} (h ⁻¹)	$k\dot{v}\left(h^{\text{-1}}\right)$	GR, O ₃ generation rate (µg h ⁻¹)
1	0.172	0.010	1126
2	0.176	0.014	1101
3	0.169	0.010	1087
4	0.168	0.011	1087
5	0.167	0.012	1084
6	0.167	0.014	1084
7	0.171	0.012	1104
Average (±2σ)	0.170 ± 0.003	0.012 ± 0.002	1096 ± 15

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194 From an average of seven experiments, the O₃ generation rate from the 222 nm lamp was

195 measured to be 1096 μ g h⁻¹ ± 15 μ g h⁻¹.

196 **Conclusions**

We measured the spectral irradiance of a commercial GUV222 lamp from 210 nm to 230 nm 197 showing a peak emission at 222 nm. Results from seven replicate experiments of the single 198 199 222 nm commercial GUV222 lamp used in this study yielded a mean O₃ generation rate of 1096 µg h⁻¹. O₃ generation rates determined in this study could be used to predict O₃ production 200 and accumulation in indoor spaces from commercial GUV222 lamps like the one used in this 201 study. The results observed in this study apply to this lamp and may vary between unit, 202 manufacturer, and test conditions. For instance, a recent study²⁴ measured an O₃ generation rate 203 204 from an unfiltered GUV222 lamp nearly ten times lower than the average value reported in this study however that study did not account for the dynamic deposition of O₃ to chamber walls 205 which likely resulted in lower measured O₃ generation rates. Like the losses of O₃ to chamber 206 207 walls and gas-phase reactions observed in this study, similar reactive losses of O₃ generated from GUV222 devices would be expected in real indoor environments with potential impacts for by-208 product formation that would affect indoor air quality.²⁵ Based on the results from this study we 209 suggest more measurements of O_3 production should be made from commercial air cleaning 210 devices employing GUV222 lamps in both real indoor and laboratory settings. 211

212 Disclaimer

Certain equipment, instruments, or materials, commercial or non-commercial, are identified in this paper in to specify the experimental procedure adequately. Such identification is not intended to imply recommendation or endorsement of any product or service by NIST, nor is it intended to imply that the materials or equipment identified are necessarily the best available for the purpose.

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